• •	Application No.	. Applicant(s)
Notice of Allowability	09/770,540	SCHUEGRAF, KLAUS F.
	Examiner	Art Unit
	Laura M. Schillinger	2813
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOR of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in the or other appropriate communion of the communication is sub-	nis application. If not included cation will be mailed in due course. THIS
1. X This communication is responsive to 1/10/2005.		•
2. The allowed claim(s) is/are 6-12,29 and 30.		
 3. ☐ Acknowledgment is made of a claim for foreign priority une a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 		(f).
2. Certified copies of the priority documents have	been received in Application I	No
3. Copies of the certified copies of the priority doc	cuments have been received in	n this national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		•
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subminiformal patent application (PTO-152) which give	tted. Note the attached EXAM is reason(s) why the oath or de	INER'S AMENDMENT or NOTICE OF heavy eclaration is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") must	t be submitted.	
(a) ☐ including changes required by the Notice of Draftsperso	on's Patent Drawing Review (PTO-948) attached
1) ☐ hereto or 2) ☐ to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the case header according to 37 CFR	drawings in the front (not the back) of 1.121(d).
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT F	SIT OF BIOLOGICAL MATER FOR THE DEPOSIT OF BIOLO	RIAL must be submitted. Note the OGICAL MATERIAL.
·		
Attachment(s)	C	must Detent Application (DTO 152)
1. Notice of References Cited (PTO-892)		mal Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		ail Date
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date		mendment/Comment
4. Examiner's Comment Regarding Requirement for Deposit	8. 🛭 Examiner's St	atement of Reasons for Allowance
of Biological Material	9. Other	

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DETAILED ACTION

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Adeel Akhtar on 04/28/06.

The application has been amended as follows:

Cancel claims 1-5 and 25-28.

Allowable Subject Matter

Claims 6-12, 29-30 are allowed.

The following is an examiner's statement of reasons for allowance: As Applicant argues in the Appeal Brief dated 1/10/05, Sekine fails to teach after making the silicon electrode rugged, replacing the silicon in the rugged electrode structure with a metal. Sekine teaches that the replacing of silicon with metal atoms causes the silicon to become rugged. This subtle distinction is made clear from Applicant's specification with teaches that the silicon layer is first made rugged by annealing or seeding the silicon layer; subsequently, a metal halide treatment acts to replace the silicon with metal. Prior art teaches forming rugged silicon electrodes through annealing and seeding, but fails to further teach nor suggest replacing the silicon with a metal as claimed by the Applicant. Moreover, Sekine teaches the replacement of silicon with metal,

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Therefore, Applicant's claims are deemed allowable over prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

however fails to teach nor suggest forming a rugged silicon layer prior to the replacing.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Laura M. Schillinger whose telephone number is (571) 272-1697. The examiner can normally be reached on M-T, R-F 7:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W. Whitehead, Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Laura M Schillinger Primary Examiner Art Unit 2813 Application/Control Number: 09/770,540

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